

Application No.	Applicant(s)	
10/672,894	BONNE ET AL.	
Examiner	Art Unit	
John P Fitzgerald	2856	

SEARCHED					
Class	Subclass	Date	Examiner		
73	23.2 31.07	8/25/2004			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
L				

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
IDS for/back, East Text Search, gas fluid, detection analysis analyzer micro chip semiconductor MEMS laborator on a chip,	8/25/2004	
gas chromotography, flow control meter, concetrator, separator, collector, flow sensor, preconcentrator, temperature,	8/25/2004	
flow sensors, thermal conductivity sensors	8/25/2004	
Inventor search Bonne	8/25/2004	